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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

| Application Serial No                                                 | 09/602,395          |
|-----------------------------------------------------------------------|---------------------|
| parist Fa 4                                                           | June 22, 2000       |
| Inventor                                                              | John T. Moore       |
| 6 i                                                                   | Microil recimology, |
| Group Art Unit                                                        | 2813                |
| Examiner                                                              | Pham, T.            |
| Attorney's Docket No.                                                 | MI22-1384           |
| Title: Methods of Forming Oxide Regions Over Semiconductor Substrates |                     |

## **RESPONSE TO DECEMBER 6, 2001 OFFICE ACTION**

To:

**Box Non-Fee Amendment** 

**Assistant Commissioner for Patents** 

Washington, D.C. 20231

From:

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## **AMENDMENTS**

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## In the Claims

**TECHNOLOGY CENTER 2800** 

Please replace the claims with the following clean version of the entire set of pending claims, in accordance with 37 C.F.R. § 1.121(c)(1)(i). Cancel all previous versions of any pending claim.

A marked up version showing amendments to any claims being changed is provided in one or more accompanying pages separate from this amendment in accordance with 37 C.F.R. § 1.121(c)(1)(ii). Any claim not accompanied by a marked up version has not been changed relative to the immediate prior version, except that marked up versions are not being supplied for any added claim or canceled claim.